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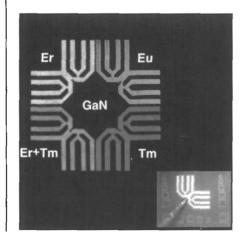
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ON THE COVER: Photo collage of rare-earth-doped GaN light-emitting devices in operation at the University of Cincinnati, demonstrating the three primary colors (red, green, and blue from Eu, Er, and Tm, respectively) plus one additive color with the (Er + Tm):GaN device in the lower left of the circle. The devices are 1.45 mm x 1.45 mm. The inset in the bottom right corner shows an illuminated GaN:Er device in operation with the electrical probe and topside contacts clearly visible. For more information, see the article by A.J. Steckl and J.M. Zavada that begins on page 33.

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I.W. Boyd, University College London Dept. of Electronic and Electrical Engineering Torrington Place

London WCI E7 JE, U.K. Tel. 44-171-380-7300 or 7302

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